



ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

LG815681390
Report verification at igi.org

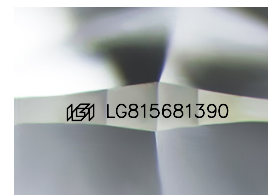
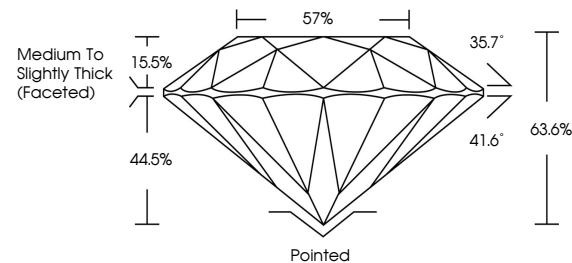
July 2, 2026	
IGI Report Number	LG815681390
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	ROUND BRILLIANT
Measurements	7.29 - 7.34 X 4.66 MM
GRADING RESULTS	
Carat Weight	1.54 CARAT
Color Grade	D
Clarity Grade	VVS 2
Cut Grade	EXCELLENT

ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	 LG815681390

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

PROPORTIONS



Sample Image Used

COLOR

D E F G H I J Faint Very Light Light

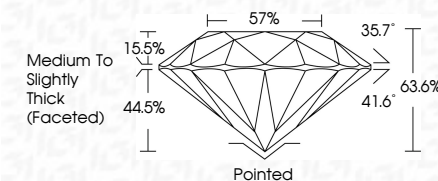
CLARITY

FL	IF	VVS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

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July 2, 2026	IGI Report No. G8916681390
ROUND BRILLIANT	
7.29 - 7.34 X 4.65 MM	1.84 CARAT
Color Grade	D
Clarity Grade	VVS 2
Cut Grade	EXCELLENT
Depth	63.6%
Table	57%
Girdle	Medium to Slightly Thick (Faceted)
Fluorescence	Pointed
Symmetry	EXCELLENT
Inscriptions(s)	EXCELLENT
	NONE
	IGI G8916681390

Comments:
The Laboratory Grown Diamond was created by Chemical Vapor Deposition process.
Type IIc